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	Application No.	Applicant(s)	Applicant(s) TAKAHASHI, NOBUYUKI Art Unit	
Notice of Allowability	10/015,804 Examiner			
	Karla Moore	1763		

Notice of Allowability	Exami	ner	Art Unit			
	Karla	Moore	1763			
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.						
1. ⊠ This communication is responsive to <u>4/30/04</u> .						
2. The allowed claim(s) is/are <u>1-15</u> .						
3. X The drawings filed on 17 December 2001 are accepted by the Examiner.						
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements 						
noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.						
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.						
 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 						
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	98),	5. ☐ Notice of Informal Page No./Mail Dat 7. ☐ Examiner's Amenda 8. ☑ Examiner's Stateme 9. ☐ Other	(PTO-413), e nent/Comment	ŕ		

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DETAILED ACTION

Allowable Subject Matter

- Claims 1-15 are allowed.
- 2. The following is an examiner's statement of reasons for allowance: The prior art of record fails to fairly teach or suggest a substrate processing device, comprising: a plurality of processing chambers, each of which administers a prescribed process to a substrate therein; a through-chamber which constitutes a vacuum chamber, the plurality of vacuum process chambers are hermetically connected to a perimeter of the through-chamber; a carry system which carries a substrate in sequence, via the throughchamber, to the plurality of vacuum process chambers, the carry system comprises a substrate holder which holds the substrate upright in such a way that a plate surface thereof forms an angle to the horizontal between 45 and 90 degrees; a horizontal movement mechanism which movers the substrate holder via the through-chamber to the plurality of process chambers; and an alignment chamber hermetically connected to the through-chamber; wherein when the substrate holder is in the alignment chamber, the horizontal movement mechanism is able to move the substrate holder such that a substrate being held in the substrate holder is able to move sideways with respect to a longitudinal direction of the plate surface thereof, as well as in the longitudinal direction thereof so as to align the carry system with the through-chamber; and wherein the alignment chamber is arranged between the throughchamber and one or more load-lock chambers.
- 3. While the prior art of record does teach or fairly suggest the majority of the claimed invention, the prior art does not fairly teach or suggest the recitation in bold above along with the requisite motivation for combination. In addition to the prior art of record, no other properly combinable piece of art was located.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should

be directed to Karla Moore whose telephone number is 571.272.1440. The examiner can normally be

reached on Monday-Friday, 8:30am-5:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor,

Gregory Mills can be reached on 571.272.1439. The fax phone number for the organization where this

application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application

Information Retrieval (PAIR) system. Status information for published applications may be obtained from

either Private PAIR or Public PAIR. Status information for unpublished applications is available through

Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC)

at 866-217-9197 (toll-free).

km

14 June 2004

P. Haminged!
Parviz Hassanzadeh
Primary Examiner

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